MISALIGNMENT DETECTOR AND IMAGE FORMING APPARATUS

CROSS-REFERENCE TO RELATED APPLICATIONS

The present document incorporates by reference the entire

5   contents of Japanese priority document, 2002-364071 filed in Japan on

December 16, 2002.

BACKGROUND OF THE INVENTION

1) Field of the Invention

10   The present invention relates to a misalignment detector for

detecting misalignment of sources of laser beams that scan a

photosensitive drum in an image forming apparatus.

2) Description of the Related Art

15   Image forming apparatuses that form one image by forming a

latent image on a photosensitive drum by each of a plurality of laser

beams have been disclosed in, for example, Japanese Patent

Application Laid-open Publication No. 2000-267027, Japanese Patent.

Application Laid-open Publication No. H6-18796, and Japanese Patent

20   Application Laid-open Publication No. H6-1002.

According to the technology disclosed in Japanese Patent

Application Laid-open Publication No. 2000-267027, a plurality of

writing optical systems are provided along a main scanning direction

and the images are joined to thereby form a wide image.   This

25   technology makes it possible to realize a low cost.

According to the technology disclosed in Japanese Patent Application Laid-open Publication No. H6-18796, separate images are written on each of a plurality of photosensitive drums by independent laser beams, each image is developed by toners of corresponding color, and the single color images are transferred, in a superimposed manner, onto a paper to obtain a multi color image. This technology is widely known as a tandem-type image forming.

According to the technology disclosed in Japanese Patent Application Laid-open Publication No. H6-1002, a plurality of writing optical systems that irradiate different laser beams write corresponding images on one photosensitive drum.

Thus, all the technologies mentioned above use a plurality of laser beams that perform scanning. However, scanning positions of the laser beams change with the temperature or the environment. Moreover, wavelength of the laser beam also changes with a change in the temperature of a laser diode that emits the laser beam. Following problems arise if the scanning positions of the laser beam change. In the technology disclosed in the Japanese Patent Application Laid-open Publication No. 2000-267027, white lines and black lines are formed at a joint between the images resulting in a deterioration of the image. In the technologies disclosed in Japanese Patent Application Laid-open Publication No. H6-18796 and H6-1002, there is a possibility of shift in image of different colors, color unevenness, spreading of color etc. resulting in deterioration of the image.

One approach to solve these problems, as disclosed in

2

Japanese Patent No. 3253227, is to detect a position of a mark that is formed in the image and correct the beam position according to the position of the mark. Particularly, to achieve high accuracy of detection of position-shift (particularly, to minimize an error in upward

5 and downward movement of a pattern), a plurality of light emitting diodes (LED), each of which forms a mark ("register mark") on the transfer belt, have been provided.

However, the requirement of a plurality of LED increases the cost. One approach to reduce the cost may be to use one LED and

10 condense the light if that LED using a condenser lens. However, not much cost reduction is realized even with this approach. On the contrary, minimum focal length of a lens in the detecting optical system is 8 mm, shortest conjugate length (while forming a magnified image) is approximately 8x4+distance between principal points of lens is not less

15 than 35 mm, and including the size of a CCD and the thickness of a circuit board, the height becomes about 40 mm. As a result, the equipment becomes bulky.

SUMMARY OF THE INVENTION

20 It is an object of the present invention to solve at least the problems in the conventional technology.

A misalignment detector according to one aspect of the present invention is used in an image forming apparatus in which a latent image is formed on a photosensitive drum by using a plurality of laser beams

25 to detect misalignment of each laser beam based on an image formed

3

on an image sensor of a position detection pattern that is formed on an image carrier. This misalignment detector includes a light source that outputs light; a synthesizing unit that passes the light of the light source so as to illuminate the position detection pattern, and collects and

5   reflects a light reflected from the position detection pattern; and a focusing unit that that focuses the light reflected from the synthesizing unit on the image sensor.

A misalignment detector according to another aspect of the present invention is used to detect misalignment of laser beams that

10   form latent images on a photosensitive drum based on detection of a position detection pattern on an image carrier. The misalignment detector includes a light source, a synthesizing unit, a focusing unit, an image sensor, and a misalignment calculator that detects the misalignment of the laser beams based on an image formed in the

15   image sensor. In this misalignment detector, the light source, the synthesizing unit, the focusing unit, and the image sensor are arranged in such a manner that light illuminated by the light source passes through the synthesizing unit so as to illuminate the position detection pattern, gets reflected from the position detection pattern, passes

20   through the synthesizing unit so as to be focused by the focusing unit on the image sensor.

An image forming apparatus according to still another aspect of the present invention includes a photosensitive drum to form a latent image by each of a plurality of laser beams; an image carrier with a

25   position detection pattern; and a misalignment detector that detects

4

misalignment of the laser beams, the misalignment detector including a

light source, a synthesizing unit, a focusing unit, an image sensor, and

a misalignment calculator that detects the misalignment of the laser

beams based on an image formed in the image sensor.   The light

5   source, the synthesizing unit, the focusing unit, and the image sensor

are arranged in such a manner that light illuminated by the light source

passes through the synthesizing unit so as to illuminate the position

detection pattern, gets reflected from the position detection pattern,

passes through the synthesizing unit so as to be focused by the

10   focusing unit on the image sensor.

The other objects, features and advantages of the present

invention are specifically set forth in or will become apparent from the

following detailed descriptions of the invention when read in conjunction

with the accompanying drawings.

15

BRIEF DESCRIPTION OF THE DRAWINGS

Fig. 1 is a side view of an image forming apparatus according to

an embodiment of the present invention;

Fig. 2 is a perspective view of the image forming apparatus

20   according to the embodiment;

Fig. 3 is an illustration to explain a principle of mark detection

according to the present invention;

Fig. 4 is an illustration to explain another principle of mark

detection according to the present invention;

25   Fig. 5 is an illustration of a line pattern to detect a position-shift

of beam in a main scanning direction;

Fig. 6 is an illustration of a line pattern to detect a position-shift of beam in a secondary scanning direction;

Fig. 7 is an illustration of a pattern to measure the position-shift

5   in the main and the secondary scanning directions simultaneously; and

Fig. 8 is an illustration of a line pattern to detect the position-shift in the main and the secondary scanning directions simultaneously.

10   DETAILED DESCRIPTION

Exemplary embodiments of a misalignment detector and an image forming apparatus according to the present invention are explained below while referring to the accompanying diagrams.   Fig. 1 is a side view of an image forming apparatus according to an

15   embodiment of the present invention.   This image forming apparatus includes a misalignment detector that includes a triangular prism 1, a triangular prism 2, a light source 3, an image sensor 4, an image forming lens 5, a shading member 6, and a circuit board 7.   The triangular prism 1 has a total reflective surface 1a and the triangular

20   prism 2 has a reflective surface 2a.   The image sensor 4 and the light source 3 are mounted on the circuit board 7.

Light beam output from the light source 3 (LED) enters the triangular prism 1 from the total reflective surface 1a and is irradiated to a surface of a photosensitive drum 10 (see Fig. 3).   This light beam is

25   reflected (hereinafter, "reflected light beam") from the surface of the

photosensitive drum 10 back to the triangular prism 1.   The reflected light beam is reflected at right angles at the total reflective surface 1a of the triangular prism 1.

When the reflected light beam is reflected from the total

5   reflective surface 1a, the reflected light beam travels parallel to the surface of the photosensitive drum 10 so that there is no need to increase the distance between the misalignment detector and the photosensitive drum 10.   The reflected light beam then passes through the image forming lens 5 and is reflected at the reflective surface 2a of

10   the triangular prism 1.   Finally, an image corresponding to the reflected light beam is formed on the image sensor 4.

A surface of the triangular prism 2 is subjected to a treatment like aliminization to form the reflective surface 2a.   It is sufficient that there is a reflective surface and it is not necessary to provide the

15   triangular prism.   When the optical axis is not to be reflected (returned) back, if a lens having a focal length of approximately 8 mm is used, the height has to be not less than 40 mm.   However, according to the present embodiment, the overall size can be made reduced to half, i.e. less than 20 mm.   Moreover, as the image sensor 4 and the light

20   source 3 are mounted on the same circuit board 7, the number of components is reduced.   This results into cost and size reduction.

The misalignment detector according to the present invention may be used in combination with the technologies disclosed in the Japanese Patent Applications Laid-open Publication Nos. 2000-267027,

25   H6-18796, and H6-1002.

7

Fig. 2 illustrates an example of an image forming apparatus, which is disclosed in Japanese Patent Application Laid-open Publication No. 2000-267027, into which the misalignment detector according to the present invention is employed. In this image forming

5   apparatus, an optical scanner scans two areas on a surface of the photosensitive drum 10 with a respective beam. This optical scanner includes a first writing system and a second writing system.

The first writing system includes a semiconductor laser 11, as a light source, that emits intensity modulated laser beam corresponding

10   to an image signal. A coupling lens 21 collimates the laser beam into a parallel laser beam. A cylinder lens 31 converges the laser beam in only a secondary scanning direction. A polygon mirror 40 deflects the laser beam.

The laser beam passes through a lens fθ that is formed by

15   lenses 51 and 61 and reflected from mirrors 71, 81, and a returning (reflecting) mirror 91, one after the other. The reflected beam forms a beam spot on the photosensitive surface (the surface that is subjected to scanning) of the photoconductive photosensitive drum 10 and scans a first scanning area S1 of the photosensitive drum 10 at a constant

20   speed. The second writing system is disposed in a position where the first writing system is rotated through 180 degrees with axis of rotation of the polygon mirror 40 as a center.

A semiconductor laser 12 which is a light source emits intensity modulated laser beam according to the image signal. The coupling

25   lens 22 makes the laser beam a parallel beam. The parallel beam is

8 ·

converged by a cylinder lens 32 in the secondary scanning direction only.   The converged beam forms an image as a long linear image in the main scanning direction around another area of deflected light by the polygon mirror 40.   The beam that is deflected at a constant

5   angular speed by the polygon mirror 40 passes through a lens $f\theta$ that is formed by lenses 52 and 62, and is reflected from mirrors 72, 82, and a returning mirror 92 one after the other.   The reflected beam forms a beam spot on the photosensitive surface of the photosensitive drum 10 and scans a second scanning area S2 of the photosensitive drum 10 at

10   a constant speed.   The first and the second writing systems are equivalent optically.   The first and the second writing systems perform writing in directions opposite to each other i.e. in directions towards two ends of the scanning area with joint of the first and the second scanning area S1 and S2, i.e. a center S0 of the overall scanning area as an

15   origin (starting point).   The first and the second writing systems include synchronized detectors 111 and 112 respectively.   The synchronized detectors 111 and 112 are installed outside an image area of scanning beams and determine timing for start of scanning of scanning beam for each scan.

20   A writing controller (circuit) (not shown) starts writing from position of start of writing (the center S0 of the overall scanning area) according to the timing determined.   Thus, the writing start position S0 for each scanning beam is common and is controlled appropriately by the synchronized detectors.   As a result, a joint in the direction of the

25   main scanning of each scanning beam can be matched appropriately.

The first and the second scanning areas S1 and S2 have to be linked as one straight line and are set to be fixed in an equipment space during designing stage of the equipment. An ideal scanning line that is set to be fixed in an equipment space is to be scanned

5 simultaneously by the two beams and is an axis of a surface to be scanned. In other words, ideally, both of the first and the second scanning areas S1 and S2 have to coincide with the surface to be scanned and be linked at the center S0.

In the joint of the first writing system and the second writing

10 system in the diagram, a position detection pattern is output and is visualized by a visualizing unit (developing unit) that is not shown in the diagram. The misalignment detector that is disposed in a downstream side of the direction of rotation of the photosensitive drum (refer to Figs. 1 and 2) reads an amount of shift in the position detection pattern that

15 is visualized. A beam position controller that is not shown in the diagram performs correction of the position.

A beam-position correcting unit for performing correction in the secondary scanning direction has been proposed in Japanese Patent Application Laid-open Publication No. Hei9-15994 (optical scanner) and

20 correction can be performed by using the known technology. A known technology can be used for performing correction in the main scanning direction.

Light incident on the triangular prism 1 is illustrated in Fig. 3. If an angle of incidence of light incident from the light source 3 on the

25 inclined surface of the triangular prism is θ_0, an angle of approach

10

(angle of penetration) inside the triangular prism 1 is θ_1, and the refractive index of the triangular prism is n1, according to Snell's law, the angle of approach (angle of penetration) $\theta1$ is indicated by

$\theta_1 = \sin^{-1}((1/n1)\sin \theta_0)$.

5   As an example, if the angle of incidence θ_0 is 60 degrees, θ_1 is 35.3 degrees.   In this case, the surface of the photosensitive drum 10 is the pattern surface for the position-shift detection and this surface is to be a surface that holds the visualized image.   A transfer paper, a carrier material of an image carrier may be used in place of this surface.   A

10   bottom surface of the prism is disposed almost in parallel to the pattern surface and since the inclined surface is at 45 degrees with respect to the bottom surface of the prism, the light falls almost vertically on the pattern surface.

Practically, since there is refraction at a surface from where the

15   light is output from the prism, when θ_0 is 60 degrees, angle of light beam on the pattern surface becomes 13 degrees.   If the angle θ_0 is about 13 degrees, the position detection error that occurs due to a shadow of unfixed toner image can be minimized to a level such that the error is negligible.   Since, a plurality of light sources are not

20   required, this can be realized at low cost.

Another example of a unit to synthesize the light is shown in Fig. 4.   In this example, instead of allowing the light to enter from the inclined surface of the triangular prism 1, a champhered portion is increased and the light is allowed to enter from the champhered area.

25   Illustrations when the pattern for position-shift detection is

formed as lines are shown in Figs. 5 and 6.   Fig. 5 illustrates an

example of a line pattern for detecting a beam-shift in the main

scanning direction and Fig. 6 illustrates an example of a line pattern for

detecting a beam-shift in the secondary scanning direction.

5   In the example in the main scanning direction, a pattern is

formed in a reading range of the image sensor 4 such that the

respective lines do not coincide.   In this case, the distance between

the lines is referred to as L0.   The lines are formed in the main

scanning direction and in the vertical direction.   To start with, outputs

10   from the image sensor 4 are added up in the secondary scanning

direction and referred to as one-dimensional data.   Distance is

measured at a peak (or a minimum value) of the lines and the

measured distance is referred to as distance between the lines.

During the measurement, if there is no shift, the distance is measured

15   as L0.   If there is a shift in the main scanning direction, the variation in

distance shown by L1 is measured.   The amount of position-shift ΔL

can be calculated by

        $\Delta L = L1 - L0$.

Since the lines are formed in parallel to the secondary scanning

20   direction and the measurement of the main scanning is not affected by

the secondary scanning shift (occurring due to optical shift and speed

unevenness of the photosensitive drum), the measurement can be

performed with high accuracy.

        While measuring the secondary scanning shift, as it is shown in

25   Fig. 6, the lines parallel to the main scanning direction are formed in the

12

reading range of the image sensor 4 such that the respective lines do not coincide. Further, outputs from the image sensor 4 are added up in the main scanning direction and referred to as one-dimensional data. Distance is measured at a peak (or a minimum value) of the lines and

5   the measured distance is referred to as distance between the lines. During the measurement, if there is no shift, the distance is measured as L0. If there is a shift in the secondary scanning direction, the variation in distance shown by L1 is measured. The amount of position shift ΔL can be calculated by

10         $\Delta L = L1 - L0$.

Since the lines are formed in parallel to the main scanning direction, the measurement of the secondary scanning is not affected by the main scanning shift (occurring due to magnification error etc. of the optical system), the measurement can be performed with high accuracy.

15   An example of a pattern while measuring the position-shift in main and the secondary scanning directions simultaneously, is shown in Fig. 7. A pattern is formed as independent dots in a position where the respective positions do not coincide even after adding up in the main and the secondary scanning directions. Size of a dot is set according

20   to the sensitivity of the sensor. Outputs from the image sensor 4 are added up in the main and the secondary scanning directions and referred to as one-dimensional data. Although the S/N ratio of the output deteriorates to some extent as compared to the line pattern, since the position of the peak is detected, the detection is performed

25   without considerable deterioration of detection accuracy. The method

13

of shift detection is the same as for the line pattern.

An example in which the detection of the position-shift in the main and the secondary scanning directions is possible simultaneously is illustrated in Fig. 8 (The method of detection is the same as in Fig.

5   7).

The misalignment detector according to the present invention may be employed in the technologies disclosed in the Japanese Patent Applications Laid-open Publication Nos. H6-18796 and H6-1002.

According to the present invention, a misalignment detector that

10   is efficiently, cheaper, and small can be obtained.

Although the invention has been described with respect to a specific embodiment for a complete and clear disclosure, the appended claims are not to be thus limited but are to be construed as embodying all modifications and alternative constructions that may occur to one

15   skilled in the art which fairly fall within the basic teaching herein set forth.